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Dated: December 8, 2004

Signature: _____

(Michael R. Hall)

10630280 *lape*
Docket No.: 29925/39488
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Letters Patent of:

Jae-Han CHA

Patent No.: 6,784,063 *B2*

Issued: August 31, 2004

For: METHOD FOR FABRICATING
BICMOS TRANSISTOR

**Certificate
DEC 20 2004
of Correction**

**REQUEST FOR CERTIFICATE OF CORRECTION
PURSUANT TO 37 CFR 1.322**

MS Post Issue
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Upon reviewing the above-identified patent, Patentee noted a typographical error which should be corrected.

APPLICATION PAGE NO.	APPLICATION LINE NO.	COLUMN NO.	LINE NO.	ERROR
Examiner's Amendment of May 21, 2004	Claim 1 Page 11, Line 10	Claim 1 Column 5	Lines 15-16	PTO

The error was not in the application as filed by applicant; accordingly no fee is required.

DEC 22 2004

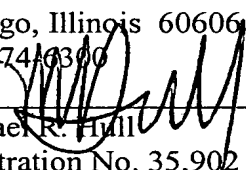
Patent No.: 6,784,063

Docket No.: 29925/39488

Transmitted herewith is a proposed Certificate of Correction effecting such amendment. Patentee respectfully solicits the granting of the requested Certificate of Correction.

Respectfully submitted,
MARSHALL, GERSTEIN & BORUN LLP
6300 Sears Tower
233 South Wacker Drive
Chicago, Illinois 60606
312-474-6300

By:



Michael R. Hull
Registration No. 35,902
Attorney for Applicant

December 8, 2004

791831

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CERTIFICATE OF CORRECTION**

PATENT NO. : 6,784,063 *B2*
DATED : August 31, 2004
INVENTOR(S) : Jae-Han Cha

It is certified that error appears in the above-identified patent and that said Letters Patent
is hereby corrected as shown below:

**Claim 1
Column 5
Lines 15-16**

After "forming a nitride film for a spacer on,"
please delete "oxide film 64 for the base spacer;"
and insert -- the structure generated by the above formations; -- in its place.

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PATENT NO. 6,784,063

No. of additional copies 3

DEC 22 2004

Application No. (if known): 10/630,280

Attorney Docket No.: 29925/39488

Certificate of Mailing under 37 CFR 1.8

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Date



Signature

Michael R. Hull

Typed or printed name of person signing Certificate

35,902
Registration Number, if applicable

(312) 474-9577
Telephone Number

Note: Each paper must have its own certificate of mailing, or this certificate must identify each submitted paper.

Request for Certificate of Correction (No Fee)

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PATENT NO. 6,784,063No. of additional copies **3****DEC 22 2004**

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